



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77760

OGATA, TOSHIYUKI, et al.

Appln. No.: 10/748,190

Group Art Unit: 1712

Confirmation No.: 5536

Examiner: Marc S. Zimmer

Filed: December 31, 2003

For: POSITIVE RESIST COMPOSITION AND BASE MATERIAL CARRYING LAYER OF  
THE POSITIVE RESIST COMPOSITION

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action dated November 4, 2005. A Petition and payment for a one-month extension of time are attached, making this Amendment due on or before March 4, 2006.

Please amend the above-identified application as follows on the accompanying pages.

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